

DOCKET NO: 263787US2PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
HIROSHI MASHIMA, ET AL. : EXAMINER: STOUFFER, KELLY
SERIAL NO: 10/518,371 :
FILED: DECEMBER 28, 2004 : GROUP ART UNIT: 1792
FOR: METHOD FOR PLASMA- :
ENHANCED CHEMICAL VAPOR
DEPOSITION AND APPARATUS FOR
PLASMA-ENHANCED CHEMICAL
VAPOR DEPOSITION

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 5, 2008, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.